

**WHAT IS CLAIMED IS:**

1. A capacitance type sensor comprising:
  - a detective member,
  - a first electrode being opposite to the detective member, and
- 5        a second electrode arranged between the detective member and the first electrode and constituting capacitance elements with the first electrode, the second electrode being displaceable in a same direction as the detective member when the detective member is displaced,
  - wherein a specified space is defined between the detective member
  - 10      and the second electrode, whereby the second electrode is not displaced until the detective member is displaced to an extent corresponding to the specified space, and
- 15        wherein the capacitance type sensor is capable of recognizing the displacement of the detective member on the basis of a detection, using a signal input to the first electrode, of a change in capacitance value of the capacitance element caused by a change in distance between the first electrode and the second electrode.
2. The capacitance type sensor according to Claim 1, which has tapered pressing members disposed in the specified space.
- 20        3. The capacitance type sensor according to Claim 1, which further comprises a single substrate on which the first electrode and the second electrode are both provided.
- 25        4. The capacitance type sensor according to Claim 2, which further comprises a single substrate on which the first electrode and the second electrode are both provided.